

SLOVENSKI STANDARD SIST-TP CEN ISO/TR 11811:2012

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Nanotehnologija - Navodila za metode nano- in mikrotriboloških merjenj (ISO/TR 11811:2012)

Nanotechnologies - Guidance on methods for nano- and microtribology measurements (ISO/TR 11811:2012)

Nanotechnologien - Leitfaden für nano- und mikrotribologische Messverfahren (ISO/TR 11811:2012) **iTeh STANDARD PREVIEW**

Nanotechnologies - Directives relatives aux methodes de mesure en nano- et microtribologie (ISO/TR 11811:2012)_{TP CEN ISO/TR 11811:2012}

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Nanotechnologies - Guidance on methods for nano- and microtribology measurements (ISO/TR 11811:2012)

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CEN ISO/TR 11811:2012 (E)

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CEN ISO/TR 11811:2012 (E)

Foreword

This document (CEN ISO/TR 11811:2012) has been prepared by Technical Committee CEN/TC 352 "Nanotechnologies", the secretariat of which is held by BSI, in collaboration with Technical Committee ISO/TC 229 "Nanotechnologies".

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

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In exceptional circumstances, when a technical committee has collected data of a different kind from that which is normally published as an International Standard ("state of the art", for example), it may decide by a simple majority vote of its participating members to publish a Technical Report. A Technical Report is entirely informative in nature and does not have to be reviewed until the data it provides are considered to be no longer valid or useful.

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Introduction

Evaluation of wear and friction in systems where interactions occur in the nanoscale is becoming increasingly important. There are two main areas of application. The first is in MEMS and NEMS devices, where tribological issues can determine the overall performance of the device. It is also true that, in many cases, the tribological performance of macroscale contacts depends on the combination of what occurs at the micro- and nanoscale asperity contacts which actually take place when two surfaces come into contact.

The development of nanotribology testing provides a way of generating information and understanding these small-scale contacts. This understanding can then be used to model the performance of microscale devices and provide the basis for future models of sliding wear.

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